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Sustainable nitrogen fixation from synergistic effect of photo-electrochemical water splitting and atmospheric pressure N_2 plasma

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Abstract. In this study, nitrogen fixation in the electrolyte was achieved by atmospheric pressure non-thermal plasma generated by a sinusoidal power supply (with an applied voltage of 10 kV and frequency of 33 kHz). Ammonia measurements on plasma exposed electrolyte at several working gas and purging gas conditions revealed that nitrogen plasma on the same gas environment is more favorable for plasma-assisted ammonia synthesis. In addition, photo-electrochemical water splitting was performed by irradiating UV light (316 nm) on a titanium dioxide semiconductor photo-anode to generate hydrogen donor in nitrogen reduction reaction. The amount of ammonia synthesized by this synergistic process of photo-electrochemical water splitting and nitrogen plasma is six times higher than that obtained by nitrogen plasma alone. An increase in the co-synthesized NO_X concentrations and background contamination at reaction site reduces the ammonia synthesis rate and Faraday efficiency. However, the ammonia production efficiency was increased up to 72% by using a proton-exchange membrane which prevent the diffusion of oxygen evolved from water splitting into the plasma, and by reducing the axial distance between the plasma electrode and reaction site. The sustainable nitrogen fixation process reported herein can be performed at atmospheric pressure conditions without a direct input of hydrogen gas or any catalyst.

Keywords: nitrogen fixation, non-thermal plasma, Ammonia synthesis, water splitting, nitrogen reduction reaction

1. Introduction

The route to industrial ammonia (NH_3) synthesis was opened by two Nobel laureates, Fritz Haber and Carl Bosch, in the early twentieth century, and the method is known as

Haber-Bosch (H–B) process [1]. About 136 million tons of NH_3 is produced annually by this process, which covers 29% of total nitrogen fixation on earth and directly benefits approximately 40% of the world's population [1, 2, 3, 4]. Currently, approximately 80% of the NH_3 produced worldwide is utilized for nitrogen based manure generation [5]. The other uses of NH_3 are explosives, pesticides, dyes, medicine, etc. Recently, other creative uses of NH_3 are being seriously considered, including refrigeration, fermentation, and energy storage [2]. The H-B process starts with the breakdown of nitrogen (N_2) triple bond [6], which is a very strong bond owing to its high bond dissociation energy of 9.1 eV $(8.7 \times 10^5 J mol^{-1})$, and ionization energy of 14.53 eV $(1.39 \times 10^6 J mol^{-1})$ [7]. This nitrogen atom reacts with hydrogen gas (H_2) over an iron-based catalyst under pressures of 150–300 atm and temperatures of $400-500^{\circ}$ C [8]. NH_3 producing industries consume 80% of the total energy demand in the chemical industry to overcome these extreme physical conditions [9]. These intensive energy and cost requirements led to the centralization of the NH_3 yield industry. Furthermore, the steam reforming of petroleum for hydrogen production involves the use of 2% of worldwide petroleum, releasing more than 200 million tons of carbon dioxide (CO_2) gas each year, which corresponds to approximately 75% of total annual greenhouse gas generation on earth [5, 9, 10]. Therefore, scientists are seeking an alternative that can overcome these inadequacies of the H–B process.

The numerous studies on non-thermal atmospheric pressure plasma (NTAPP) suggested that it is a potential alternative to the high-temperature and pressure technique for the synthesis of numerous compounds such as benzene and isooctane [2, 11, 12, 13, 14]. Nowadays, the electrochemical reduction of nitrogen to ammonia induced by plasma sources is seen as an alluring hitherto alternative to the H–B process [8]. The main advantages of plasma-assisted nitrogen fixation are that it obviates the necessity of extremely high temperatures and pressures, requires renewable energy sources, and avoids the emission of greenhouse gases like CO_2 [9, 15]. In non-thermal plasma, the electron temperature is in the range of few-electron volts [16]. The impact collision between the N_2 ($N \equiv N$) and electrons (e^-) has sufficient energy to break or weaken the triple bond of N_2 [16]. The weakened triple bond can then be broken with additional energy provided by the NTAPP. These atomic nitrogen react with the hydrogen ions (H^+) in the plasma and the plasma/liquid (P/L) interface, thus forming NH_3 [17, 16] in the presence of aqueous electrons (e^-_{ag}) [8].

In most of the studies on plasma-assisted NH_3 synthesis, the process starts with the hydrogen evolution reaction (HER) from plasma exposed water/liquid via ultraviolet (UV) irradiation [6, 7, 9], electrolysis [3], electrocatalytic [18], electrochemical [8, 19], or direct chemical reactions [20]. This evolved hydrogen reduces the plasma generated atomic and vibrationally excited nitrogen into ammonia. The main reaction pathways of plasma-assisted nitrogen fixation is summarized in figure 1. However, the development of a method for an efficient HER from a sustainable and low-cost process is of great

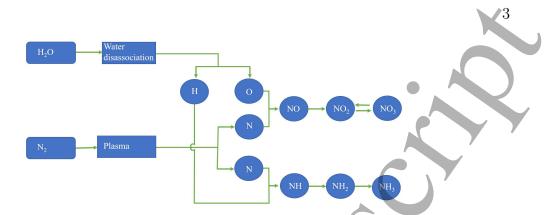


Figure 1. Plasma-assisted nitrogen fixation reaction pathways

importance. One of our main enthusiasm is encouraged to generate hydrogen from the photo-electrochemical decomposition of water, which could be a hydrogen donor in nitrogen reduction reaction (NRR). Titanium dioxide (TiO_2) is an effective semiconductor for photo-electrochemical and photocatalytic water-splitting under the irradiation of UV light of less than 382 nm wavelength [21, 22, 23, 24, 25]. Herein, we noticed that the hydrogen generated from the photo-electrochemical decomposition of water increased the plasma-assisted NH_3 synthesis rate. To increase NRR rate, other metal-oxide semiconductor as a sacrificial reaction catalyst has been used in various study [26, 27, 28] but till now synergistic interaction of metal-oxide semiconductor induced HER and non-thermal atmospheric pressure plasma in NRR has hardly been discussed. The novel nitrogen fixation method presented in this experiment is environmentally friendly, and the photo-generated hydrogen will be accessible in various locations at a low cost.

2. Experimental setup and methodology

Figure 2(a) schematically illustrates the concept of our four electrode configuration used for sustainable plasma-assisted nitrogen fixation. A custom built plasma jet was fabricated by inserting a stainless steel syringe electrode with a length of 40 mm and outer and inner diameters of 0.9 mm and 0.6 mm, respectively, inside a quartz tube of length 56 mm and outer and inner diameters of 4 mm and 2 mm, respectively. A 2 mm wide copper tape was used for peripheral ground by wrapping around the quartz tube, which is located 5 mm below the needle electrode. To synthesize NH_3 in the electrolyte, a glass reaction cell sealed with a polystyrene lid was prepared and a portion (10 mm) of quartz tube 3 mm below the ground was inserted through the lid and the distance of surface of the electrolyte and nozzle of the quartz tube was maintained at 3 mm unless it is stated. Unlike the other common plasma-assisted nitrogen fixation processes such as lightning and the Birkeland–Eyde process [29, 30], two holes were also drilled for the inlet and outlet of the purge gas with a flow rate of 2000 sccm to remove the background contamination. When working gas with a flow rate of 1000 sccm was supplied with an alternating sinusoidal voltage of $\sim 10 \text{ kV}$ (peak) to the syringe electrode with

a repetition frequency (f) of 33 kHz, plasma was generated between the high-voltage syringe electrode and the copper ground electrode and propagated along the direction of working gas flow to reach the electrolyte surface.

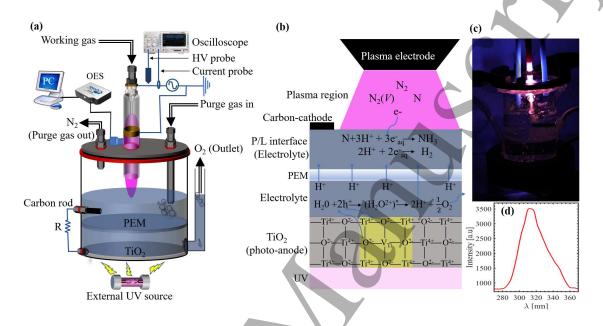


Figure 2. (a) Schematic diagram of N_2 plasma jet impinging on the electrolyte at the cathode side of the photo-electrochemical water splitting reaction cell together with a proton exchange membrane (PEM). (b) Potentially important species in the plasma region are vibrationally excited N_2 species and atomic nitrogen (N), and those in the water are aqueous electrons (e_{aq}^-) and H^+ transported through the PEM. The overall reactions involved in the nitrogen reduction reaction generating NH_3 in the P/L interfacial region are shown. (c) Photograph of the experimental setup. (d) Optical spectrum of UV source used in experiment.

To achieve the HER through photo-electrochemical water splitting, two other electrodes were constructed for the photo-electrochemical reaction cell (PECRC). Generally, PECRC for water splitting is made up of UV exposed photo-anode, photo-cathode and electrolyte. A 0.05-cm-thick circular TiO_2 layer with a diameter of 3.8 cm coated over the glass substrate was used as the anode of the cell. This anode completely covered the bottom of the reaction cell. A carbon rod was used as the cathode of the cell, and both the electrodes were immersed in 40 ml of 0.01 M H_2SO_4 electrolyte ($pH \sim 2$). The cell anode was irradiated with a UV lamp (Sankyo Denki G4TE5, Japan) of 15 W and a peak wavelength of 319 nm (3.9 eV) from the bottom of the reaction cell for effective disassociation of water into oxygen and protons (H^+). For selective transportation of H^+ from the anode to the cathode, a 25.4 μm -thick Nafion 211 film used as a proton exchange membrane (PEM) was placed in the middle of the cell electrodes. We performed several experiments at different working and purging gas with and without UV, the cell electrodes, and PEM in the reaction cell and the obtained result was characterized by the corresponding nitrogen-based compounds formed in the plasma-exposed electrolyte.

During the synergic interaction, the transport and reduction of H^+ at the cell cathode, and the interaction of the vibrationally excited nitrogen species or atomic nitrogen and electron coming from the nitrogen plasma with the hydrogen ion in the plasma liquid (P/L) interface to form NH_3 are shown in figure 2(b). Similarly, photograph of the experimental setup is shown in figure 2(c) and in figure 2(d) optical spectrum of UV lamp used in experiment is shown.

The discharge voltage and current were measured using a Tektronix P6015A highvoltage probe and a LeCroy CP030 current probe, respectively, and the measured voltage and current waveforms were monitored using 434 LeCroy wideband digital oscilloscopes. Photo-biased voltages and corresponding currents were measured by a multimeter (Fluke 287 true RMS multimeter) and recorded by a software (Fluke view forms). Optical emission spectroscopy (OES) was performed 3 mm below the peripheral ground using a HR4000+CG-UV-NIR (Ocean Optics, Inc.) spectrometer with the help of an optical fiber whose diameter is 400 μ m. The spectrometer was calibrated for wavelength measurements using a Hg-Ar lamp (Newport Corporation, model: 6048). Quantitative measurement of NH_3 in the plasma exposed electrolyte was performed by a fluorometric method using a $QuantiFluo^{TM}$ Ammonia Assay Kit (DNH3-200) (Bio-Assay Systems). The assay is based on an improved o-phthalaldehyde method [31]. This reagent reacts with NH_3 and forms a fluorescent product. The fluorescence intensity ($\lambda_{ex/em} = 360/450$ nm) is proportional to the NH_3 concentration in the sample. Similarly, the quantitative colorimetric determination of NO_x (NO_2^- , and NO_3^-) at 540 nm was performed using an improved Griess reagent kit [32] (BioAssay Systems, D2NO-100). The concentration of species in the electrolyte was determined from the calibration curves obtained from the absorbencies of compounds of known concentrations, which were determined following the manufacturer's instructions. Respective fluorescence and absorbance of the sample were measured by microplate reader (BioTeK Gen5). Similarly, Faradaic efficiency (η) of NH_3 synthesis measured in this experiment was calculated from the give relation [8].

$$\eta[\%] = \frac{Measured\ NH_3\ concentration}{Faradaic\ NH_3\ concentration} \times 100\%.$$
(1)

Faradaic NH_3 concentration = q/FnV. Here, q is for total charge flowing through the external circuit of reaction cell and F (= 96485 $Cmol^{-1}$, is Faraday's constant, n (= 3) is the number of electron required for ammonia synthesis and V (= 40ml) is total volume of electrolyte.

3. Results

3.1. Electrical and optical characteristics of plasma

The typical voltage and current waveforms of plasma discharge are shown in figure 3(a). The several discharge current (I) peaks in the rising part of the discharge voltage (V) are

generated by the accumulation of wall charges (Q) on the inner side of the quartz tube during discharge. These discharge currents were measured as a few tens of milliamperes with duration of a nanosecond to tens of nanoseconds. At the negative alternate of

the voltage waveform, these accumulated charges were reversed in the negative voltage polarity, which generated similar current peaks in the negative direction. the corresponding charge $(Q = \int Idt)$ versus voltage (Lissajous figure) is shown in figure 3(b). When the applied voltage across the electrodes is not high enough to generate a plasma, the charge versus voltage plot shows a straight line. However, when the applied voltage is adequate to cause the discharge of N_2 gas, the charge in the circuit increases or decreases sharply according to the discharge. In this case, the Lissajous figure becomes a parallelogram and the area of the closed-loop (parallelogram) is equal to the discharge energy (E) dissipated in each cycle [33, 26]. The power dissipated during discharge can be calculated by multiplying the area with frequency. The energy dissipated per cycle was calculated as follows [33]

$$E = \int_{t=0}^{t=T} VIdt = A_{lissajous}.$$
 (2)

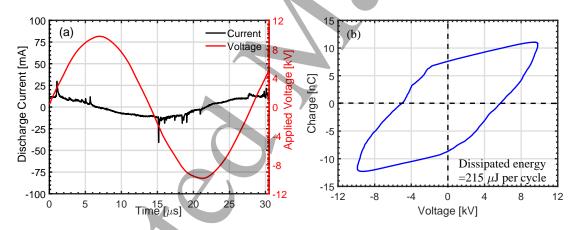


Figure 3. Electrical characteristics of discharge. (a) Current (black) and voltage (red) waveforms of discharge current versus time plot. (b) Plot of corresponding charge versus voltage. [Working gas: nitrogen; gas flow rate in the main tube: 1000 sccm.]

The area of the Lissajous figure in our experiment was calculated as 215 μJ . All the plasma measurements were performed at an applied power of $P = E \times f = 7.1W$

Numerous reactive oxygen and nitrogen species are delivered during the plasma discharge in the air ambient. In the gas phase, depending on the injected energy, working and surrounding gas, dissociation of working gases and water molecules by the energetic electrons in the discharge and UV photolysis mostly leading to the formation of various reactive oxygen and intro gen species including excited species through several reaction pathways. Figure 4 shows a typical optical emission spectrum of nitrogen plasma recorded 3 mm below the peripheral copper ground with 7.2 Watt plasma input power. The emission profile from 200 to 400 nm is mostly composed of reactive nitrogen

species including NO_{γ} (200-280) [34], N_2 second positive system (SPS) (311–380 nm) corresponding to the transition $N_2(C^3 \prod_g - B^3 \prod_g)$ [35, 36], and N_2 first negative system (FNS) (around 400 nm) corresponding to the transition $N_2^+(B^2 \sum_u^+ - X^2 \sum_u^+)$ [35]. A weak emission from hydroxyl radicals (OH) corresponding to the transition $A^2 \sum_{u=0}^{+} (v^u = 0) - X^2 \prod_u (v^u = 0)$ is also observed at 309 nm [35]. This is due to the dissociation of water molecules presents in the working gas by electrons or metastable atoms [37]. In addition to this, weak peaks atomic nitrogen at 742, 822, and 868 and atomic oxygen at 777 nm and 845 nm [38] has also been seen. For greater visualization, the range of 700–900 nm is magnified in the inset of Figure 4

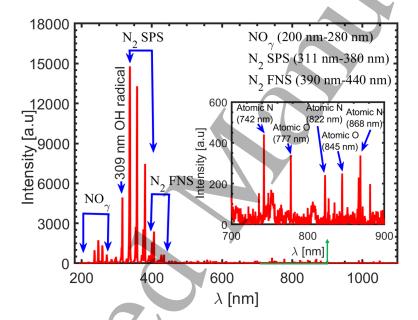


Figure 4. Optical emission spectrum of plasma measured 3 mm downstream the peripheral ground. [Working gas: nitrogen; gas flow rate in the main tube: 1000 sccm; applied voltage: 10 kV; frequency: 33 kHz].

3.2. Total nitrogen fixation for various configurations and controls

We initially performed a series of experiments to identify the most favourable working and purging gas condition for NH_3 production. Figure 5 shows the average concentrations of NH_3 and NO_X produced in the electrolyte after 30 minutes of plasma exposure for the following configurations: (i) Argon (Ar) gas is used for both working and purging gas; (ii) Ar plasma and air purging gas; (iii) Ar plasma and N_2 purging gas; (iv) N_2 plasma and Ar purging gas; (v) N_2 plasma and air purging gas; and; (vi) N_2 is used for both working and purging gas; In this experiment, plasma was normally exposed on electrolyte without photo-electrochemical water splitting reaction cell and external UV source. In the complete set of data trials of Ar plasma, no detectable amount of NH_3 was found. Here, as expected, main products are measured to be NO_X . As we

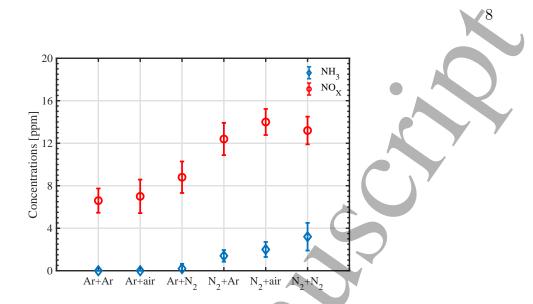


Figure 5. Concentrations of NH_3 and NO_X produced in 40 ml of acidic electrolyte during 30 min of plasma exposure for the following working and purging gas configurations: (i) Argon (Ar) gas is used for both working and purging gas; (ii) Ar plasma and air purging gas; (iii) Ar plasma and N_2 purging gas; (iv) N_2 plasma and Ar purging gas; (v) N_2 plasma and air purging gas; and; (vi) N_2 gas is used for both working and purging gas

manipulate the background argon gas by air and nitrogen in argon plasma, only NO_X concentrations was measured to be increased but NH_3 is still undeteactable/negligible. In contrast with Ar plasma, NH_3 was also found to be increased with NO_X in nitrogen plasma when we alter the argon background with air and nitrogen. In nitrogen plasma, the quantity of NH_3 was small in comparison with NO_X however, it was significantly measurable. The NH_3 synthesis rate in nitrogen plasma was increased by 50% when argon environment is altered by nitrogen environment. These measurements confirmed that N_2 plasma on the same gas environment notably enhanced the NH_3 synthesis rate. On behalf of this result, in the proceeding experiment nitrogen gas is used for both working and purging gas.

The interaction of nitrogen plasma with water activates the production of different nitrogen based product in the water, which alters the chemical composition of water. Figure 6 shows the average concentrations of NH_3 and NO_x produced in the electrolyte after 30 min of nitrogen plasma exposure at the following configurations: (i) only plasma without photo-electrochemical water splitting; (ii) plasma with UV exposure on electrolyte without photo-electrochemical water splitting; (iii) Combined effect of plasma and photo-electrochemical water splitting without PEM; (iv) Combined effect of plasma and photo-electrochemical water splitting with PEM; and (v) No plasma, only nitrogen gas is passed on photo-electrochemical water splitting reaction cell. Only 3 ppm NH_3 was produced by only plasma, while the NO_X concentration was approximately 6 times more than the NH_3 concentration at this configuration. Next, when the plasma exposed

₽O

electrolyte was also exposed by external UV light source from bottom of reaction cells as in configuration (ii), the NH_3 concentration slightly increased to 8 ppm, whereas the NO_X concentration drastically increased to 28 ppm. After that, plasma was exposed on the photo-electrochemical water splitting reaction cell without PEM, the NO_X and NH_3 concentration further increased to 35 ppm and 11 ppm, respectively. For configurations (i)-(iii), the NH_3 concentrations were significantly lower than NO_X concentrations. However, after embedding a PEM inside the electrolyte of photo-electrochemical water splitting reaction cell as described in configuration (iv), the NH_3 concentration was increased more sharply to 19 ppm but NO_X concentration was decreased to 15 ppm. In this configuration, NH_3 leads the NO_x concentration, in contrast to the previous configuration. A comparison of configurations (iii) and (iv) revealed that the PEM is responsible for the increase in NH_3 concentration by 72% and the decrease in NO_x concentration by 57%. Besides this, to study the direct interaction between N_2 gas and the evolved hydrogen, N_2 gas was passed (without plasma) on photo-electrochemical water splitting reaction cell. No nitrogen-based product was detected in the electrolyte during this process.

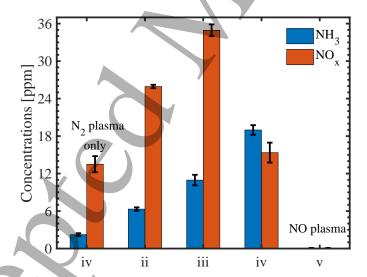


Figure 6. Concentrations of NH_3 and NO_X produced in 40 ml of acidic electrolyte during 30 min of plasma exposure for the following configurations: (i) only plasma without photo-electrochemical water splitting; (ii) plasma with UV exposure on electrolyte without photo-electrochemical water splitting; (iii) Combined effect of plasma and photo-electrochemical water splitting without PEM; (iv) Combined effect of plasma and photo-electrochemical water splitting with PEM; and (v) No plasma, only nitrogen gas is passed on photo-electrochemical water splitting reaction cell.

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In the subsequent experiment, we studied the temporal variations in NO_X and NH_3 concentrations after the combined effect of nitrogen plasma and photo-electrochemical water splitting reaction with and without PEM. Which is shown in figure 7(a). The concentrations of all nitrogen based products $(NH_3 \text{ and } NO_X)$ increased linearly with an increase in plasma exposure time in both the configurations. In absence of PEM, NO_X is quite higher than NH_3 concentration but after insertion of PEM the overall trend is reversed. This evidences that the overall nitrogen fixation is more significant in the absence of a PEM but the utilization of a PEM leads to the selective production of NH_3 . Furthermore, corresponding variation of Faradaic efficiency for NH_3 synthesis is presented in figure 7(b). Maximum 48% faradaic efficiency was measured without PEM but with PEM it increased to 91%. Results presented in this figure indicates that, the average faradaic efficiency increased by 35% after implantation of PEM.

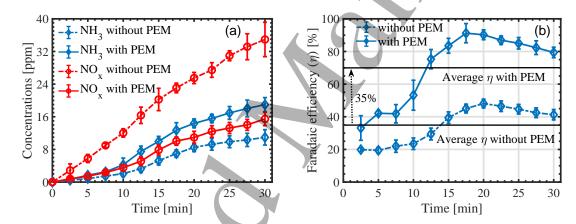


Figure 7. Temporal variations in (a) NO_X and NH_3 concentrations (b)Faradaic efficiency for NH_3 synthesis in the electrolyte during the synergistic interaction of photo-electrochemical water splitting and nitrogen plasma with and without PEM.

Next to this experiment, spatial variation of NO_X and NH_3 concentrations synthesized by the combined effect of nitrogen plasma and photo-electrochemical water splitting in presence of PEM was investigated and obtained result is presented in figure 8. Different from the aforementioned experiment, axial distance between the nozzle of the quartz tube and surface of the electrolyte (Z) is varied by from 0-7 mm by shifting the plasma jet in upward direction (away from the electrolyte) in this experiment. From this result, Both NO_x and NH_3 concentration in plasma exposed electrolyte decreased with increase in axial distance but NH_3 concentration decreased more sharply than NO_x concentration. Here, the average concentration of NO_x and NH_3 diminished by 2 and 3 fold every millimeter in axial direction, respectively. The average NH_3 and NO_X concentrations decreased slowly while increasing the axial distance from 0 mm to 3 mm, after that, it falls more sharply. As seen in figure 8, at z=0 mm NH_3 concentrations was about 21 ppm with high error but at z= 3 mm it was about 19 ppm

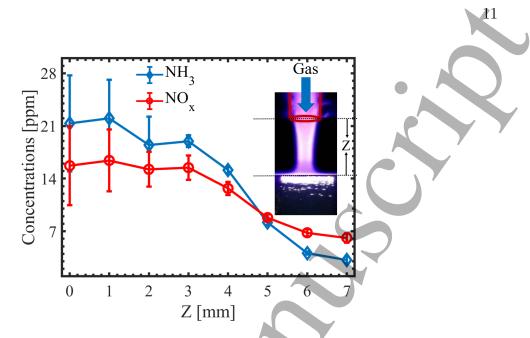


Figure 8. Spatial variation of NO_X and NH_3 concentration synthesized by the synergistic of photo- electrochemical water splitting and plasma in nitrogen plasma exposed electrolyte in configuration.

with low error values. Afterward it was sharply reduced to 5 ppm at 7 mm. Thus, the moderate distance between the nozzle of the quartz tube and surface of the electrolyte is advantageous in this experiment to achieve a higher synthesis rate at greater consistency. In this experiment, when the nozzle of the quartz tube is very close to the surface of the electrolyte, plasma generation is disturbed by water droplets coming from the splash of water caused by the gas flow. As a result of this disturbance, highly fluctuated concentrations of NH_3 and NO_X was obtained at z <3 mm.

4. Discussion

Photo-electrochemical water splitting converts photon energy into electrical energy in a cell comprising two electrodes immersed in an aqueous electrolyte. In this experiment, a semiconductor, TiO_2 , was used as the photo-anode and exposed to light for photon absorption, and a conductor, carbon rod, was used as the cathode. If the energy of the photon $(E = h\nu)$ is equal or greater than the band gap of TiO_2 , the electrons jump to the conduction band (CB), leaving holes in the valance band (VB) [23]. The light-induced intrinsic ionization of TiO_2 resulting in the formation of quasi-free electrons (e^-) in the CB and holes (h^+) in the VB is illustrated in figure 9(a). The band gap of TiO_2 is approximately 3.2 eV [21], and the threshold wavelength required to form a charge carrier pair in this semiconductor as shown in equation (3) is approximately 382 nm.[23].

$$2h\nu \to 2e^- + 2h^+. \tag{3}$$

Then, the photo-induced holes oxidized the water molecules into gaseous oxygen and hydrogen ions on the surface of TiO_2 , as presented in equation (4). The detailed

mechanism of water oxidation at the oxygen vacancies present on the surface-active sites of TiO_2 has been discussed elsewhere [21, 23].

$$2h^+ + H_2O \to \frac{1}{2}O_2 + 2H^+.$$
 (4)

Threshold energy E_t required for equation (3) is [21]

$$E_t = \frac{\Delta G_{H_2O}^0}{2N_A} = \frac{237.141 k J mol^{-1}}{2 \times 6.023 \times mol^{-1}} = 1.23 eV.$$
 (5)

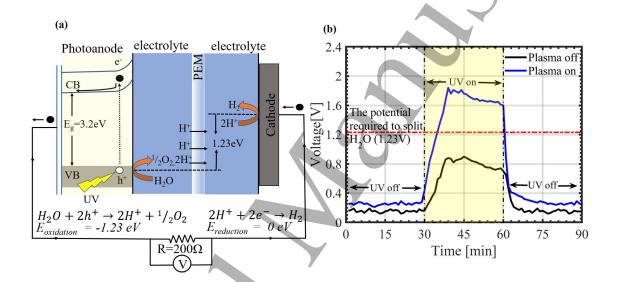


Figure 9. (a) Mechanism of electron-hole pair formation on TiO_2 photo-anode by UV irradiation, oxidation of water at the photo-anode, transport of H^+ through the PEM, and reduction of H^+ at the cathode. (b) Effect of UV-irradiated TiO_2 with and without plasma exposure of the electrolyte on photo-biased voltage.

Where, $\Delta G_{H_2O}^0$ is the standard free enthalpy per mole of reaction and N_A is Avogadro's number. Electrochemical water splitting is feasible only when the potential difference between the two cell electrodes is equal to or greater than 1.23 V. Even though the band gap of TiO_2 is approximately 3.2 eV [21], the photo-biased voltage between the two electrodes is only ~ 0.7 –0.9 V owing to its high corrosion resistance [21]. The effect of UV light on photo-biased voltages is shown in figure 9(b). These plots were recorded during plasma off and plasma plume touching the electrolyte surface. As can be seen, the photo-biased voltage reached its maximum within a few minutes of exposing the photo-anode to UV and returned to its initial background value within a few seconds of switching off the UV light. The photo-biased voltage generated within the cell in the absence of plasma is less than that required for water decomposition as calculated by equation (5). After turning on plasma, when electrolyte is encountered by plasma at the cathode side of reaction cell, deposition of charge on the electrolyte contribute sufficient biased voltage for water splitting. In this presented result, photo-biased voltage of 1.8

V was achieved that was enough for water decomposition. The oxygen evolved from equation (4) cannot diffuse through the PEM so it escapes out through the outlet from the anode side of the reaction cell. Only H^+ ions transport toward the cathode in the cell through the PEM. At the same time, the electrons transfer to the external circuit and the cathode, where hydrogen ions (H^+) are reduced into hydrogen, as presented in equation (6) [25]

$$2H^+ + 2e^- \to H_2.$$
 (6)

The electrons generated by plasma also injected into the interfacial surface of the electrolyte [13]. These electrons are responsible for the formation of vibrationally excited nitrogen species and atomic nitrogen in the plasma phase through collision excitation, direct ionization, and step-wise ionization. Then, these electrons and vibrationally excited nitrogen species and atomic nitrogen transported to the aqueous electrolyte. The overall breakdown reaction of N_2 triple bond in the plasma phase is shown in equation (7). These nitrogen atoms could electrochemically combine with H^+ and e_{aq}^- at the plasma-liquid interface as in equation (8) [8, 39],

$$N_2 + e^- \to 2N + e^-.$$
 (7)

$$N + 3H^{+} + 3e_{aq}^{-} \to NH_{3}.$$
 (8)

Nitric oxide (NO), nitrite (NO_2) and nitrate (NO_3) can form in the plasma/plasmaliquid interface via several possible pathways. In the main reaction pathway, Reactive nitrogen species react with the OH radicals produced by plasma initiated UV photolysis [40, 41], as shown in equation (9) to form NO, NO_2 and NO_2 via mechanism as in equations (10),(11) and (12) [9, 14]:

$$H_2O + UV \rightarrow H + OH.$$
 (9)

$$N + OH \to NO + H. \tag{10}$$

$$NO + OH \rightarrow H + NO_2.$$
 (11)

$$NO_2 + OH \rightarrow H + NO_3.$$
 (12)

The formed NO_X species dissolved in the liquid transform very fast to NO_2^- and NO_3^- through the equations (13) and (14) [42, 43]

$$NO_2(aq) + NO_2(aq) + H_2O(l) \to NO_2^- + NO_3^- + 2H^+.$$
 (13)

$$NO(aq) + NO_2(aq) + H_2O(l) \to 2NO_2^- + 2H^+.$$
 (14)

The formed NH_3 will also immediately dissolve in the acidic electrolyte because the trapping of these nitrogen compounds is significantly higher in acidic media than in neutral and basic media [8]. The further increase in NO_X concentrations in the absence of a PEM as seen in figure 6 and 7 is possibly due to Telestich's reactions [44] caused

by the interaction of oxygen with the nitrogen plasma. Oxygen and hydrogen ion ions obtained from equation (4) or hydrogen atom from equation (6) directly interact with the nitrogen plasma at the interfacial region of the electrolyte and gas environment. The reactive nitrogen species tend to form more stable compounds in a liquid since the reactions in equations (10),(11) and (12) are faster than reaction in equation (8) [9] so main products obtained in the liquid phase were NO_X . Owing to the electron scavenging effect of dissolved NO_X , the NH_3 concentration further decreased with an increase in NO_X concentration.

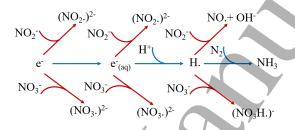


Figure 10. Ammonia production pathway (blue) together with e^- and H scavenging reactions of dissolved NO_2 and NO_3 (red).

The crucial role of aqueous electrons (e_{ag}^-) on NH_3 synthesis has already been verified by scavenging experiments elsewhere [8]. The scavenging effect and the formation of other new reducing radical species such as $(NO_2)^{2-}$, $(NO_3)^{2-}$ are presented in figure 10. The high reactivity of dissolved NO_X with e_{aq}^- could effectively control the formation of NH_3 because the absorption rate of the electron by NO_X (red reactions in figure 10) is 500 times faster than N and H combination [8] (blue reactions in figure 10). The decrease in NO_X concentrations in the presence of a PEM, as seen in the results of figure 6 and 7 is attributed to the extinct Zeldovich's reactions at the reaction site due to a lack of surrounding environment of oxygen; subsequently, more NH_3 was formed and it became the dominant nitrogenous compound in the electrolyte. Distribution of NH_3 and NO_X concentrations is directly affected by electron density, energy and abundance of the reactive nitrogen species. It has been also reported that, energy, electron density and the reactive species generated by plasma jet are delivered to the electrolyte which is higher at lower axial distance and continuously decrease with the downstream propagation of plasma plume [45]. In this presented work, the electron density continuously reduced from $5.23 \times 10^{13} \ cm^{-13}$ to $1.17 \times 10^{13} \ cm^{-13}$ with increase in axial distance from o mm to 7 mm, respectively. Which has been measured using a method described in our previous publication [37]. Electrons delivered to the electrolyte is a major source of solvated electron (e_{aq}^-) therefore the rate of NH_3 formation is decreased with increase in axial distance as seen in the figure 8

Considering their performance, the HER from the photo-electrochemical water

splitting was better than that from the electrolysis of water [3], electrochemical reduction of water [8, 19], and UV induced dissociation of water [6, 7, 9] for NH_3 synthesis. A commercial membrane electrode assembly (MEA) electrolyzer is available for electrochemical water splitting; however, according to Kumari et al. [3], the direct plasma exposure of the costly MEA electrolyzer causes several drawbacks such as the gradual degradation of MEA performance via a sputtering mechanism, dehydration of electrode, and difficulties in the stabilization of current after plasma exposure. Nevertheless, in this photo-electrochemical water splitting, the current stabilized within 2-5 minutes and no physicochemical change was observed in the PEM after the operation, which was confirmed by contact angle measurements. The contact angle of PEM did not change and was $73.16^{\circ} \pm 0.53^{\circ}$ before and after the 4-hour operation. Next, superiority of our experiment over others previously reported HER technique [3, 19, 6, 7, 9] is also verified by Faradaic efficiency measurement as presented in figure 7(b). The average Faradaic efficiency of NH_3 synthesis in this experiment is surprisingly higher than those of other previously reported plasma-assisted nitrogen fixations (2–60%) [15, 46, 47, 48] and also quite stable than the report of Hawtof et al. [8].

The energy consumption of the H–B process is approximately 9-13 $kWhkq^{-1}$ [1, 8] using natural gas, coal, or fuel oil as feedstock. However, in this experiment, the energy consumption (= Power/NH₃ production rate) was $\sim 4500 \ kWhkg^{-1}$, which is much higher than that of the H-B process and lower than that of other previously reported plasma-assisted NH_3 synthesis process ($\sim 17000 \ kWhkg^{-1}$ [46]. Plasma-assisted NH_3 synthesis could be a potential competitor of the H-B process if the Faradaic efficiency can be improved by the selective production of NH_3 , which remains a challenge [49, 50] because plasma simultaneously produces a bulk variety of by-products. H_2 resources will not remain a challenge in the future because water splitting has great potential similar to the steam transformation of petroleum [21, 22, 23, 24]. Thus, we developed a novel method that integrates the photo-electrochemical water splitting method with a plasma system for nitrogen fixation and obtained expected results. In our experiment, NH_3 is the desired product; however, the concentrations of NO_x formed in the electrolyte were also analyzed, which could add extra value to the nitrogenous compound. It is obvious that a higher selectivity is required in the cell, which could be achieved using a catalyst in the future. Nevertheless, our approach could be a milestone for applying the HER via photo-electrochemical water splitting in plasma-assisted NRR to ammonia. Considering the overall cost associated with the establishment, production, transportation, and storage, the plasma technology could be an economic and environment friendly approach for localized small-scale production of ammonia at a site of use such as farmland.

5. Conclusions

In this experiment, the cathode side of the electrolyte was exposed to non-thermal atmospheric pressure nitrogen plasma in a photo-electrochemical water-splitting

reaction cell. The atomic nitrogen generated from plasma electrochemically react with the hydrogen ion generated from UV-induced water oxidation at the TiO_2 photo-

anode. A practical advantage of this method is that ammonia can be achieved from nitrogen gas and water at ordinary temperatures and pressures without any catalyst and sacrificial reagent. The interaction of vibrationally excited nitrogen species generated by plasma with the oxygen evolved from the water dissociated is responsible for the higher concentration of NO_X in the absence of a PEM. However, when a PEM was implanted, the selective transportation of hydrogen ion towards the reaction site reduced the NO_X formation rate and significantly enhanced the ammonia synthesis rate and efficiency (up to 91%). Consequently, NH_3 became the dominant nitrogenous product in the plasmaexposed electrolyte at lower axial distance between plasma electrode and electrolyte. Despite the current challenges, plasma technology will provide opportunities to direct the ammonia production industry toward a sustainable process in the future.

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